

Electronic Patent Application Fee Transmittal

Application Number:	10759925			
Filing Date:	16-Jan-2004			
Title of Invention:	Semiconductor processing with a remote plasma source for self-cleaning			
First Named Inventor/Applicant Name:	Kiyoshi Satoh			
Filer:	Andrew N. Merickel/Sara Cornwell			
Attorney Docket Number:	ASMJP.055C1			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	120	120

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				300